



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of  
Gerhard SCHNEIDER et al.

Atty. Docket No.:  
5196/ETCH/CONE/JB1

Appln. No.: 09/834,501

Group Art Unit: 1763

Filed: Apr. 12, 2001

Examiner: L. Alejandro  
Mulero

Conf. No.: 5799

Title: MUSHROOM STEM WAFER  
PEDESTAL FOR IMPROVED  
CONDUCTANCE AND UNIFORMITY

\* \* \* \* \*  
AMENDMENT UNDER 37 C.F.R. § 1.111  
\* \* \* \* \*

Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

In reply to the Office Action mailed August 20, 2002, the period for reply having been extended by petition to February 20, 2003, please amend the above-identified patent application as follows:

IN THE CLAIMS:

Cancel claims 1-11.

Amend claims 12-15 so that claims 12-19 read as follows:

12. (Once Amended) A processing system for simultaneously processing two semiconductor articles under substantially identical process conditions, the processing system comprising:  
a chamber body having a bottom wall with a pumping port